



**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 1763
PATENT**

Customer No. 22,852

Attorney Docket No. 7553.0019-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chishio KOSHIMIZU et al.

Application No.: 10/675,966

Filed: October 2, 2003

For: **PLASMA PROCESSING
APPARATUS AND PLASMA
PROCESSING METHOD**

Group Art Unit: 1763

Examiner: KACKAR, RAM N

Confirmation No. 6290

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the final Office Action mailed March 7, 2005, the period for response having been extended to September 7, 2005 by a Petition for Extension of Time - Three Months and appropriate fee payment, and pursuant to 37 C.F.R. § 1.116, Applicants respectfully request that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.

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